

Patent Gazette

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METHOD FOR MANUFACTURING HIGH-PURITY METAL

Brief Description of the Drawings

The drawings illustrate an example of the apparatus for implementing the method of the present invention. Figure 1 is a horizontal cross section along the B-B line in Figure 2, and Figure 2 is a vertical cross section along the A-A line in Figure 1.

Detailed Description of the Invention

The present invention relates to a method for manufacturing high-purity metal by using a plasma jet to cause a material to be reduced (such as a silicon halide or titanium halide) to undergo pyrolysis or a reaction with hydrogen.

With conventional methods for manufacturing high-purity metal, the reaction was limited to a relatively low temperature [in order to avoid] contamination from the reaction vessel or the softening and melting of the vessel material. Consequently, the reaction yield and the reaction velocity were both low. Furthermore, since the reaction was usually conducted at a temperature under the melting point of the precipitated metal, the precipitate had to be removed in solid form [from the reactor]. Due to this restriction, the reaction was not generally conducted continuously. In addition, the reactor was inevitably bulky for the amount of material it produced.

Advantages to the method of the present invention include the following:

- 1. Because the reaction is conducted at an extremely high temperature, the reaction velocity is high, and the raw material yield is good.
- 2. Because the reaction precipitate is taken off in the liquid phase, continuous operation is possible.
- 3. Because the portion of the reaction vessel where the product is precipitated is cooled, and the surface thereof is entirely covered with low-temperature precipitate, no contamination from the vessel will be caused by outflow of the liquid precipitate.
- 4. The apparatus is more compact than in the past.

Next, the apparatus used to implement the present invention will be described in detail through reference to the example shown in the drawings. In Figures 1 and 2, a doubled-walled copper vessel 1 is cooled by cooling water flowing in from [a port] 3 and out of [a port] 4. Electrodes 2 provided to the vessel 1 are made of a metal such as tantalum and are connected to a DC power supply 6 via a terminal 7. When the electrode gap is adjusted and an electrical load applied, an arc is generated between the electrodes. Thoroughly refined hydrogen gas is then introduced from [a port] 5, at which point the arc becomes an extremely high temperature plasma jet that is sprayed into the vessel 9. A material that has been thoroughly refined and is to be reduced is then introduced from [a port] 8 and brought into the jet in the form of a gas or liquid, whereupon these [materials] are mixed in the jet flow and either pyrolyzed or reduced into high temperature hydrogen by the high temperature of the jet, which results in the targeted metal being precipitated. The metal produced here is in the form of particulate gas, but since the walls of the vessel 9 onto which the jet is sprayed are being cooled by water, the jet flow touches and is cooled by these walls, and the precipitated metal forms a solid on the walls and adheres thereto. As this operation is continued, liquid metal ends up being deposited on the walls and flows out from a port 10. The outflowing metal is cast into a mold and solidified. Any unreacted gas and the reaction product gas are discharged through [this port] 10 to the outside of the vessel.

Arc voltage: 150 V

Arc current: 130 amperes
Hydrogen flux 50 L/min
Refined silicon tetrachloride flux: 35 g/min

A 2.5 kg block of silicon was obtained using 25 kg of silicon tetrachloride under the above conditions. This silicon had a purity of about 99.999999[%], which was more than good enough for a semiconductor material.

¹ Translator's note: Literally "two-coat" in the original, but the intended meaning seems clear from the context.

Claims

1. A method for manufacturing high-purity metal, characterized in that a plasma jet is generated by a standard method using refined hydrogen, a metal material that has been refined and is to be reduced is introduced into this plasma jet flow and either pyrolyzed or reacted with hydrogen, causing said metal to precipitate, and this [metal] is liquefied in a cooling vessel and allowed to flow out.

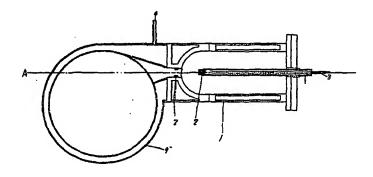


Figure 1

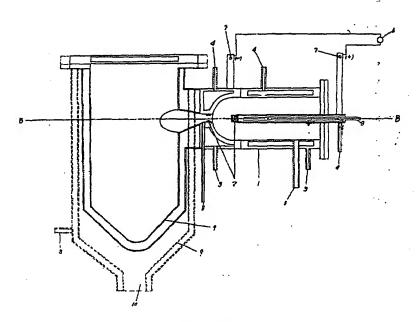


Figure 2

特許出顧公告

昭38—6854

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(全2頁)..

純度金属の製造法

配面の簡単な説明

図面は本発明の方法を実施する装置を例示したもので 第1回は第2回のB-B兼における横断平面図、第2回 は第1回の人一人祭における疑断何面図。

代理人 弁理士

発明の詳細な説明

本発明はプラズマジェットを使用し被還元材料(けい 素へロゲン化物、テチンへロゲン化物等)を熱分態又は 水窯と反応させ高純度金属の製造法に関するものである。

従来の高純度全真の製造方法は反応容器からの汚染又 は容器材質の軟化融解のため反応温度が比較的低温度に 制約されている。従って反応収率が低く且つ反応速度も 小であった。更に、新出金属の融点以下の包度で反応さ せることが多いため折出物を塊状で取り出す関係上反応 は袋屋から制約をうけて一般に不連続に行われている。 又生産量に比し袋健は大型のものとならざるを得なかつ

しかるに、本発明の方法の利点は

- 1 反応が極めて高温とおいて行われるため反応速度が 速く且つ原料収率が良好である。
- 2 反応析出物が被相で取り出されるため連続機業が可
- 3 反応容器の生成物析出部を冷却し、その表面を低温 度の折出物で全面的K被覆するから折出物が液状に無 出しても姿勢からの汚染はない。
- 4 装置は従来のものに比し小型である。

次に、図面に一例として示した本発明を実施する症骸 二家旅よりたる銅製容器では多より施入すより流出する。。 冷却水によつて冷却されて滑る。 容器 1 に付属する電極 2はメンタルその他の全異であつて増于7を経で臣流電・・

額6枚姿貌されている。電極間隔を調整し、電力を負荷 すると電極間にアークが発生する。次いで5ょり充分に 特製された水素ガスを流入させるとアークが極めて高温 のプラズマジェットとなつて答答9 内に嗅出する。 次い でおより充分に特製された被威元材料を気製又は被駁で ジェット中に差入すると、これらはジェット気流中に起っ 入し、ジェットの高量に依り動分解又は高温の水準に依 り還元され目的の金襴を折出生成する。この時の生成金 殿は春位孤気状であるがジェットの噴出する容器9の壁 面が水冷されているからジェクト気流はこの壁面に触れ 冷却され折出金属は壁面に固体となって折出附着する。・ 更に操作を離脱すると壁面に液態の金属が折出するに至 り流出口10℃流出する。流出金属は美型で美込まれ間 化せられる。未反応気体及び反応生成気体は10を軽て 容石外に排出される。

アーク電圧 .

150V.

雷涛

130アンペア

50 Pmin 特製四塩化けい常流量 35g/min

以上の条件で四塩化けい第25時を使用し2.5 時の 塊状シリコンを得た。とのものは99.999999 程度 の範囲をもち半導体用材料として充分なものであった。

特許関求の範囲。

| 特製された水常を使用し通 の方法によつてプラズ マジェットを発生させ、このブラズマジェット気流中化・ 精製された被量元金属材料を導入し、これを熱分解また について詳細に副明する。第1回及び第2回において、 は水常と反応させ当該金属を折出させ、とれを序知容器 中で液化統出させるととを存載とする高純資金県の製造

